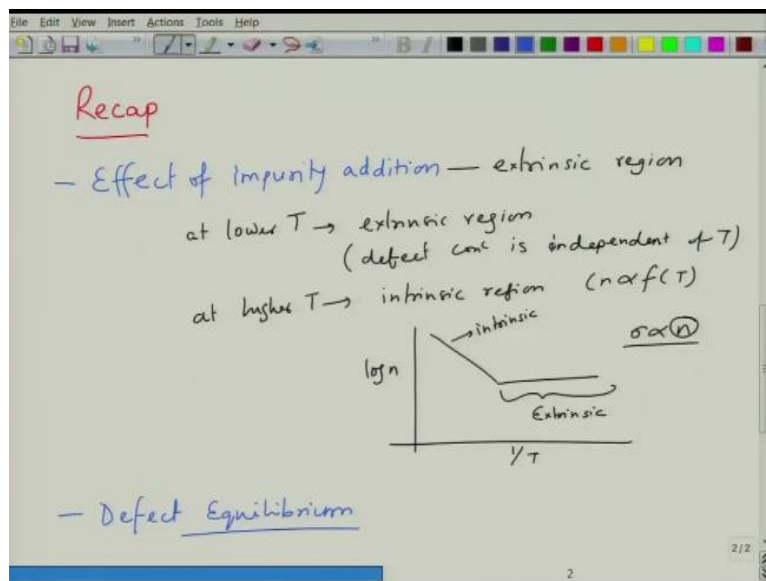


**Fundamentals and Applications of Dielectric Ceramics**  
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**Lecture - 12**  
**Defect Concentration: Non Stoichiometric Oxides**

So, welcome again to the new lecture of this course fundamentals and applications of dielectric ceramics. So, we will just briefly do a recap of what we did in the last lecture.

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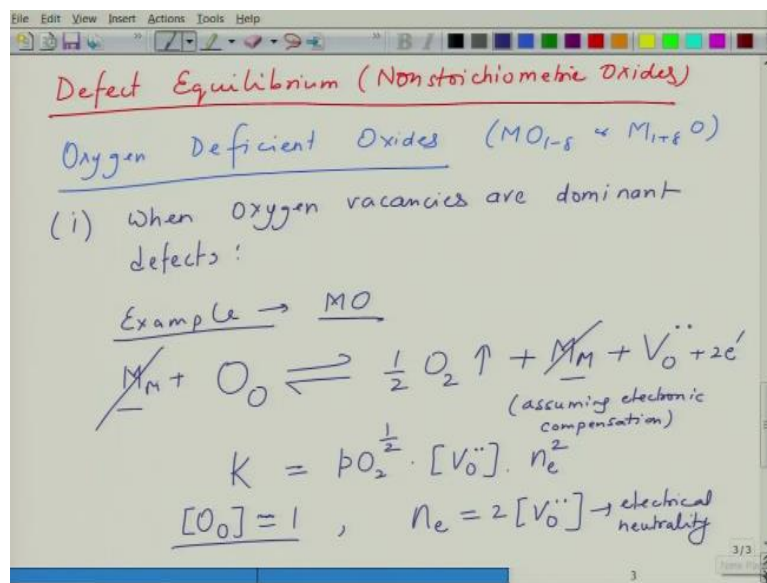


So, in the last lecture, we looked at effect of impurity addition. So, effect of impurity addition leads to formation of extrinsic region when you plot concentration versus temperature. So, generally at lower temperature, you will have extrinsic region where defect concentration is independent of temperature okay, and at higher temperature, you will have intrinsic region where  $n$  will be a function of temperature and generally the plot will look like this. So, if you have  $\log n$  as a function of  $1/T$ .

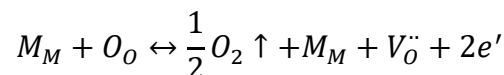
So, this is the higher temperature region, this is a lower temperature region, so this would be your extrinsic region and this would be intrinsic region okay and this is also reflected in properties such as conductivity and diffusivities and things like that, where you will see that because of constant defect concentration, the conductivity also remains constant as a function of temperature because conductivity is proportional to  $n$ . So, as a result despite having some dependence on temperature, it virtually remains constant up to certain temperature because of constant defect concentration which is high and then we looked at the defect equilibrium.

So basically, we wanted to establish conditions as a function of ambient conditions. So, in the case of stoichiometric solids or stoichiometric defects, the concentration of defects is basically dependent upon temperature only, it does not depend upon the conditions like partial pressure, oxygen, etc and the denominator whether you will have  $2kT$  or whether you will have  $3kT$ ,  $4kT$  or whatever, it will depend upon the stoichiometry of oxides. For  $MO$ , it would be  $2kT$ , for  $M_2O_3$  and  $MO_2$ , it could be different.

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So, let us now further develop on the same thing. We were looking at the defect equilibrium in non-stoichiometric, so we are looking at the case of oxygen deficient oxides okay. So basically, it is a case of either  $MO_{1-\delta}$  or  $M_{1+\delta}O$  okay. So, let us say the first case which is when oxygen vacancies are dominant defects. So, if example is of  $MO$ , then the defect reaction can be written as



so, oxygen at oxygen site goes out okay, leaving at, so metal at metal site will remain, so if you just write so metal at metal site remains at metal at metal site, which means metal sites are conserved.

Oxygen site to maintain the site conservancy will become empty. So, this will become  $V_O$  and the compensating defects will be 2 electrons if you consider electronic compensation okay. So, this is assuming electronic compensation. If you consider ionic compensation, you will not form electrons, rather you will have a reduction of metal ions okay. So, that is what is going to

happen. So, basically now, if you want to write down the defect, so you can basically write down that reaction constant.

$$K = pO_2^{1/2} \cdot [V_{O}^{\bullet\bullet}] \cdot n_e^2$$

,we can ignore  $M_M$  because  $M_M$  is canceled on both sides, if I say electron concentration as  $n_e$ , it becomes  $n_e$  square okay. So, it becomes a product of vacancy oxygen, vacancy concentration multiplied by electron concentration square multiplied by  $pO_2$  to the power half and here we are assuming that  $O_O$  is equal to 1 okay.

$$[O_O] = 1, \quad n_e = 2[V_{O}^{\bullet\bullet}]$$

So, we assume that  $O_O$  is equal to 1, which is basically the case of ideality and to maintain the electrical neutrality, what is the electrical neutrality condition, the electrical neutrality condition is that for every oxygen we can see we are creating 2 electrons, which means  $n_e$  is equal to twice of okay, this is electrical neutrality alright.

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$$K = pO_2^{1/2} \cdot [V_{O}^{\bullet\bullet}] \cdot (2[V_{O}^{\bullet\bullet}])^2$$

$$K = 4 [V_{O}^{\bullet\bullet}]^3 \cdot pO_2^{1/2}$$

$$[V_{O}^{\bullet\bullet}] = \left(\frac{K}{4}\right)^{1/3} \cdot pO_2^{-1/6}$$

temp dependent
Oxygen ( $pO_2$ ) dependence

So, when you write this and if you substitute this in the above equation, it becomes,

$$K = pO_2^{1/2} \cdot [V_{O}^{\bullet\bullet}] \cdot (2[V_{O}^{\bullet\bullet}])^2$$

So, if you now just rearrange it, this  $K$  will become.

$$K = 4[V_{O}^{\bullet\bullet}]^3 \cdot pO_2^{1/2}$$

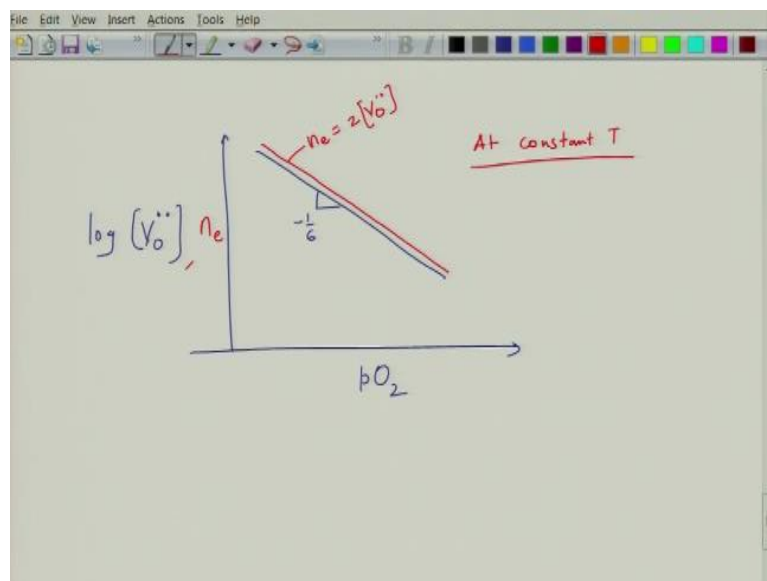
So, I can write this as now  $V_O$  being if I just want to express  $V_O$  now, so this becomes.

$$[V_{O}^{\bullet\bullet}] = \left(\frac{K}{4}\right)^{1/3} \cdot pO_2^{-1/6}$$

So, of course  $K$  can be written from the usual free energy reaction and this will become some  $K_1$  into exponential of minus delta H by  $kT$ .

So, temperature dependence will be in-built here, but what is important here is in addition to dependence upon temperature, so this is temperature dependent because  $K$  will show the temperature dependence, but this is additionally what we see is oxygen, partial pressure of oxygen dependence. So, what this shows you is that as you increase the partial pressure of oxygen, the vacancy concentration will go down, and as you decrease the partial pressure of oxygen, the vacancy concentration will go up.

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So, when you plot this, when you plot  $V_O$ , so you can plot this as a function of you know for log plot, semi log plot okay. So, let us say  $\log V_O$ ,  $pO_2$ . So, the vacancy concentration will decrease as a function of  $pO_2$  and this will we have a slope of  $-\frac{1}{6}$ . You can also plot on the same plot by electron concentration,  $n_e$ , which is twice of  $V_O$ , so basically this line would be, it will run parallel right. So, this is  $n_e$ , which is twice of  $V_O$ .

So, this is what we see that in case of non-stoichiometric oxides in addition to temperature dependence which will be similar to what you have. So, this is at constant temperature okay. So, at a constant temperature, the vacancy of, oxygen vacancy and electron concentration will go down as you increase the partial pressure of oxygen. So, basically as you reduce the partial pressure of oxygen, you will make oxygen more and more oxygen deficient and you will create more and more vacancies and consequently electrons in the system, that is how you make a defect prone oxide okay, right.

Now, why should  $n_e$  be constant,  $n_e$  is twice of  $V_O$ . So, for every vacancy you create, you are creating 2 electrons. So,

as you increase the vacancy concentration, the electron concentration will also increase or decrease as depending upon the condition okay. So, this is the condition when you have oxygen vacancies present.

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When metal interstitials are dominant defects

$$M_M + O_O \rightleftharpoons M_i^{\cdot\cdot} + \frac{1}{2} O_2 \uparrow + 2e'$$

two sites are destroyed to maintain site ratio

$$K = [M_i^{\cdot\cdot}] p_{O_2}^{1/2} \cdot n_e^2$$

$$[M_M] = [O_O] = 1 \quad \text{as } M_i \ll M_M \ll O_O$$


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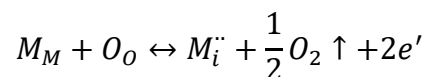

$$n_e = 2 [M_i^{\cdot\cdot}]$$

$$\frac{n_e}{2} = [M_i^{\cdot\cdot}] = \left(\frac{K}{4}\right)^{1/3} p_{O_2}^{-1/6}$$

$\log M_i, n$

Graph showing  $\log M_i, n$  vs  $p_{O_2}$  with a slope of  $-\frac{1}{6}$  and a dashed line labeled  $n$ .

Now, let us see what will happen when metal interstitials are dominant. So, when metal interstitials are dominant defects, then we can write it



So, we have site valence the metal has lost its site and gone to interstitial site, oxygen has lost its site, gone out. So, these 2 sites are destroyed right to maintain site ratio right okay. So, for one oxygen site destroyed, you will have altered destroy the metal site, that is why it becomes metal interstitial.

So, now when you write the defect reaction for this,

$$K = [M_i^{\cdot\cdot}] \cdot p_{O_2}^{1/2} \cdot n_e^2$$

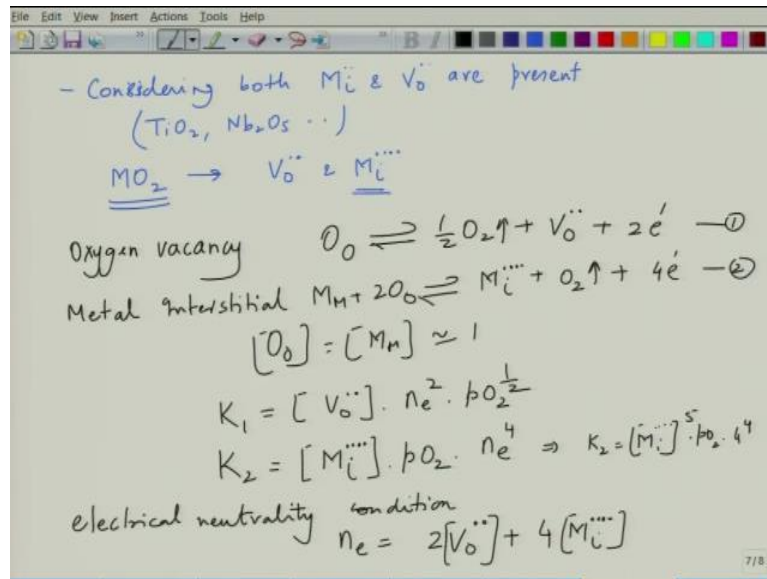
, and we can take these  $M_M$  okay considering ideal situation, especially when  $M_i$  is very small as compared to  $M_M$  and  $O_O$  okay because there are more metals and oxygens, then interstitial, and what is the electrical neutrality condition, that says that  $n_e = 2 M_i$  okay, you are creating 2 electrons for every metal interstitial.

So, now you can do the math yourself, so if you do this substitution, you will have

$$\frac{n_e}{2} = [M_i^{\cdot\cdot}] = \left(\frac{K}{4}\right)^{1/3} \cdot pO_2^{-1/6}$$

So, again you can make the plot and the plot will be similar to the previous plot where you did plot  $M_i$ ,  $n_e$  both on log scale as a function of  $pO_2$  and as you increase the  $pO_2$ , the metal interstitial concentration will decrease and this is the electron concentration, this is  $n$  and this is  $M_i$  right.

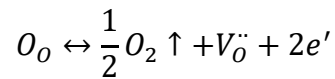
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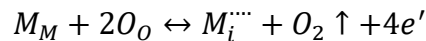
Now, a little tricky one, the tricky one is what happens when both of them are present. Now, the previous cases could be when vacancy formation energy is very low as compared to metal interstitial forming energy or metal interstitials form very easily as compared to vacancies. Now, there could be situations where both energies are sort of comparable okay, then there is a possibility that both of them could be present and this is for example in  $TiO_2$  or even in niobium oxide, these are scenarios.

So, lets say we take a case of  $MO_2$  okay, we do not take a case of just to reflect the oxide, we take a case of  $MO_2$ . So, if we take a case of  $MO_2$ , in case of  $MO_2$ , we will have oxygen vacancies as vacancy defects and we will have metal interstitial which will be 4 positive charges interstitials okay. So, for every metals interstitial, so you will consider for charge valence for every metal interstitial, you will have 2 oxygen vacancies right. So, let us say we have defect reactions.

So, we write the defect creation for oxygen vacancy okay, let me just use a different color. So, for oxygen vacancy, we first write as oxygen and oxygen site, goes out of system, this creates a vacant oxygen site plus this gives rise to 2 electrons.



For metal interstitial, I can write this as,



You can write the same thing for MO also, and considering that  $O_O = M_M = 1$ , they are very large number as compared to defects.

We can write the defect reactions as, so if I take this as 1, this as 2, for 1, I can write K1 as

$$K_1 = [V_O^{\bullet\bullet}] \cdot n_e^2 \cdot pO_2^{1/2}$$

$K_2$ , I can write as

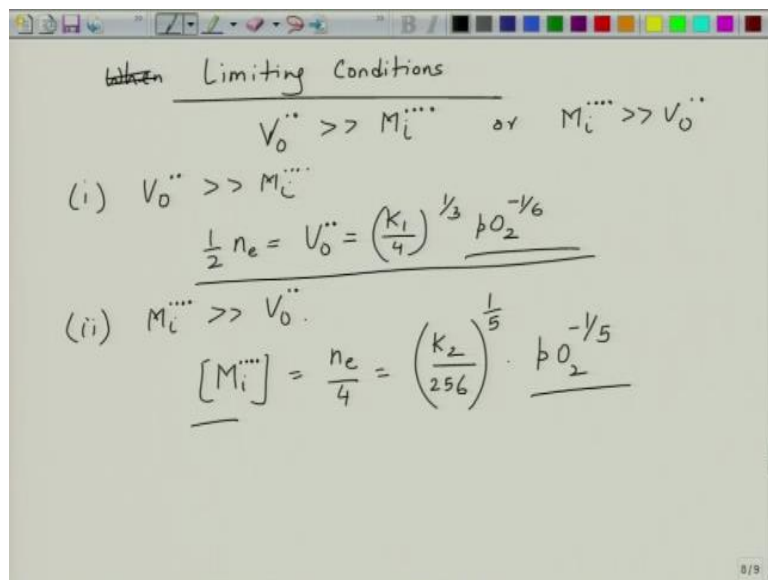
$$K_2 = [M_i^{\bullet\bullet\bullet\bullet}] \cdot pO_2 \cdot n_e^4$$

Now, what is the electrical neutrality condition,

$$n_e = 2[V_O^{\bullet\bullet}] + 4[M_i^{\bullet\bullet\bullet\bullet}]$$

, depending on which one dominates, or it has to be balanced right. So, this will be the electrical neutrality condition. So, you can consider cases.

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So, the first case is when, so limiting cases, we consider limiting cases right. Limiting conditions will be when  $V_O$  is very large as compared to  $M_i$  or it could be when  $M_i$  is very

large as compared to  $V_o$  okay. So, we consider these limiting conditions. The limiting condition let us say,

(i)  $V_o \gg M_i$

$$\frac{1}{2} n_e = V_o = \left(\frac{K_1}{4}\right)^{1/3} \cdot pO_2^{-1/6}$$

This is straightforward. This you will have to work out a little when  $M_i$  is greater than  $V_o$ .

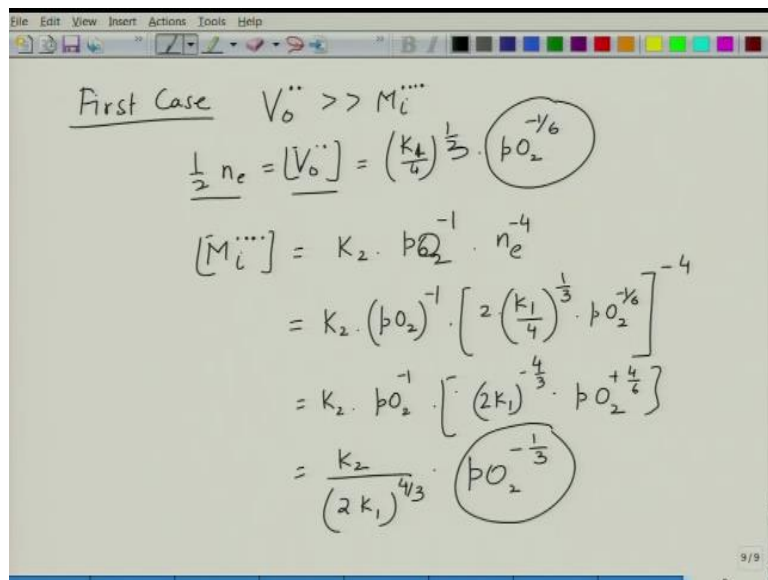
(ii)  $M_i \gg V_o$

then  $n_e = 4M_i$  okay. So  $n_e = 4M_i$ , you will have to substitute it there. So, it will become 4 to the power 4 into  $M_i$  to the power 4 right. So, basically it will become  $M_i$  to the power 5, if you multiply by this  $M_i$ . So,  $M_i$  will be equal

$$[M_i] = \frac{n_e}{4} = \left(\frac{K_2}{256}\right)^{1/5} \cdot pO_2^{-1/5}$$

So, this is what you will have situations like. So, you will have  $M_i$  showing a dependence of  $(-1/5)$  and oxygen showing a dependence of  $(-1/6)$ . So, now in both of these regimes, you would like to calculate what is the corresponding metal interstitial concentration and what is the corresponding oxygen vacancy concentration.

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So, let us say the first case, the first case was when  $V_o$  was much greater than  $M_i$  okay. So, in the first case, we can calculate,

$$\frac{1}{2} n_e = [V_o] = \left(\frac{K_1}{4}\right)^{1/3} \cdot pO_2^{-1/6}$$



So, we have got the expressions for  $n_e$  and  $V_O$ , but we do not know how the  $M_i$  is going to vary in this regime. So  $M_i$  is written using the  $M_i$  formula, so  $M_i$  formula is basically the second equation, which is simplified as,

$$[M_i^{\bullet\bullet}] = K_2 \cdot pO_2^{-1} \cdot n_e^{-4}$$

$$[M_i^{\bullet\bullet}] = K_2 \cdot pO_2^{-1} \cdot \left[ 2 \left( \frac{K_1}{4} \right)^{1/3} \cdot pO_2^{-1/6} \right]^{-4}$$

$$[M_i^{\bullet\bullet}] = K_2 \cdot pO_2^{-1} \cdot \left[ (2K_1)^{-4/3} \cdot pO_2^{4/6} \right]$$

$$[M_i^{\bullet\bullet}] = \frac{K_2}{(2K_1)^{4/3}} \cdot pO_2^{-1/3}$$

So, for the first case when oxygen vacancies dominate over metal interstitials, then your  $M_i$  goes as  $pO_2$  to the power  $-1/3$  and an oxygen vacancies go as  $-1/6$ .

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Second Case when  $M_i^{\bullet\bullet} \gg V_O^{\bullet\bullet}$

$$M_i^{\bullet\bullet} = \frac{n_e}{4} = \left( \frac{K_2}{256} \right)^{1/5} \cdot pO_2^{-1/5}$$

$$[V_O^{\bullet\bullet}] = K_1 \cdot n_e^{-2} \cdot pO_2^{-1/2}$$

$$= K_1 \cdot \left[ \left( \frac{K_2}{256} \right)^{-1/5} \cdot pO_2^{1/5} \right]^{-2} \cdot pO_2^{-1/2}$$

$$= \frac{K_1}{(256)^{2/5}} \cdot pO_2^{-(2/5 + 1/2)}$$

$$= \frac{K_1}{16} \cdot pO_2^{-10/10}$$

$$K_2 = \left( \frac{K_2}{256} \right)^{1/5}$$

$$\frac{-\frac{1}{2} + \frac{2}{5}}{-5 + 4} = \frac{1}{10}$$

For the second case when  $M_i$  dominance over  $V_O$  okay, when  $M_i \gg V_O$ , we calculated the expression for  $M_i$ . So,

$$M_i^{\bullet\bullet} = \frac{n_e}{4} = \left( \frac{K_2}{256} \right)^{1/5} \cdot pO_2^{-1/5}$$

Now, we would like to calculate what is  $V_O$  in this case. So,  $V_O$  in this case can be calculated using the first equation, the first equation says that

$$[V_O^{\bullet\bullet}] = K_1 \cdot n_e^{-2} \cdot pO_2^{-1/2}$$

So, you replace  $n_e$  from there,

$$[V_{\ddot{O}}] = K_1 \cdot [K_2' pO_2^{-1/5}]^{-2} \cdot pO_2^{-1/2}$$

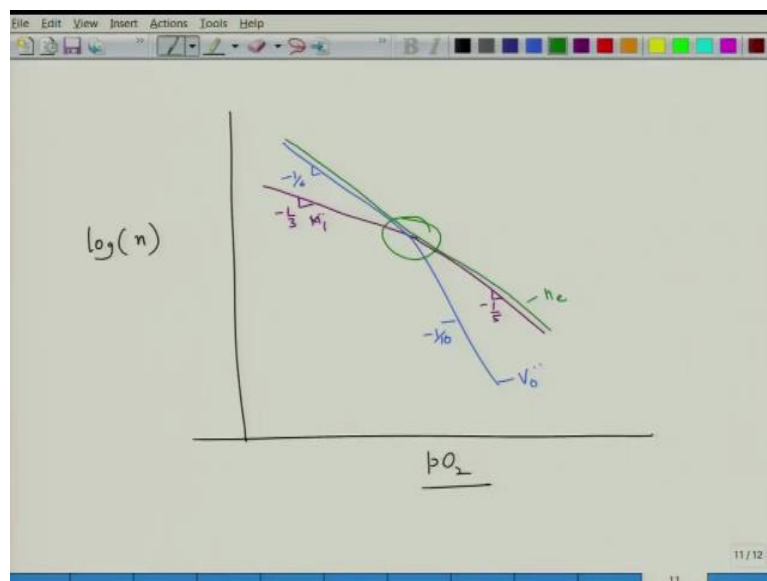
$$[V_{\ddot{O}}] = K_1 \cdot [K_2' pO_2^{-1/5}]^{-2} \cdot pO_2^{-1/2}$$

$$[V_{\ddot{O}}] = \frac{K_1}{(K_2')^2} \cdot pO_2^{-1/2+2/5}$$

$$[V_{\ddot{O}}] = \frac{K_1}{16} \cdot pO_2^{-1/10}$$

So, in this regime, oxygen vacancy has a dependence of  $-1/10$  and  $M_i$  has a dependence or  $-1/5$ . So, this is how now when you want to make a plot of these and  $n$  will follow basically the dominant defect, whether it will follow  $V_{\ddot{O}}$ , it will follow  $M_i$ .

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So, if you now want to plot this log of let us say defect concentration I just write as  $n$  okay and then I write it as  $pO_2$  okay. So, I see that defect concentration. So, let us first plot the vacancy concentration, oxygen vacancy concentration goes as  $pO_2$  to the power  $-1/6$  okay and then it goes as  $pO_2$  to the power  $-1/10$  okay. So,  $pO_2$  to the power  $-1/10$  is obviously, so let us first draw this when oxygen vacancy dominates, then let us say  $-1/6$  the first case.

So, the magnitudes will of course depend upon the value of  $K_1$  and  $K_2$  and so on and so forth, but generally the trend would be something like this. So, we saw that in certain regime, the

oxygen vacancy concentration goes as  $-1/6$  okay, then the oxygen vacancy concentration is  $-1/10$ . So, initially it is minus  $-1/6$  and then becomes  $-1/10$ . So, this is  $-1/6$ , this is  $-1/10$ . So, this is for let us say  $V_O$  okay. The  $M_i$  if you look at the variation of  $M_i$ , the  $M_i$  in this case goes as  $-1/3$  okay.

So, when oxygen vacancy goes as  $-1/6$ ,  $M_i$  goes as  $-1/3$ . So,  $M_i$  would be something like, if I use a different color, this would be  $M_i$  Okay. So, this will go as  $-1/3$ . So, this is  $M_i$ , and if you look at the second region, the second region the  $M_i$  goes as  $-1/5$ . So, it will go sort of in this fashion  $-1/5$  and the electron concentration in the first case to follow this line, in the second case to follow this line. In the first case, it will go as  $-1/6$ , in the second case it will go as  $-1/5$  okay.

So, this will be the line of  $n_e$  okay. So, that is how the electron impurity concentrations will vary when you have mixed effects, there will be crossover regime and it is not perfect, there may be this region can be even more complex okay, the crossover region, but this is how roughly the variation of defect concentration will be as a function of partial pressure of oxygen when you have mixed presence okay.

So, what we have done in this class is we have looked at the variation of defect concentration as a function of partial pressure of oxygen when one particular defect dominates and what happens when two defects coexist together. So, we elaborate up on this further in the next lecture. Thank you.